



**Applied Materials Enhanced CVD TxZ  
Process chamber  
Vintage 2007 300mm**

# Applied Materials Enhanced CVD TxZ Process chamber

## Vintage 2007 300mm

### Location warehouse Nijmegen condition "As is"

**Manufacturer:** Applied Materials  
**Type:** 300mm Enhanced CVD (MOCVD) TxZ  
 Process chamber  
**Date of manufacture:** 2007  
**Serial nr :** 40769

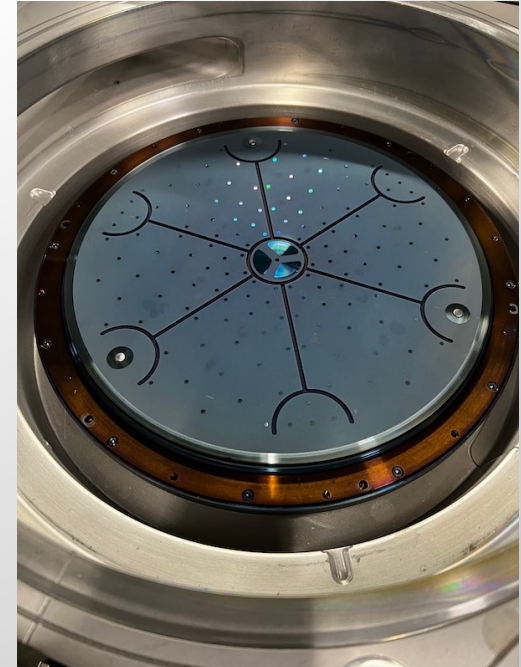
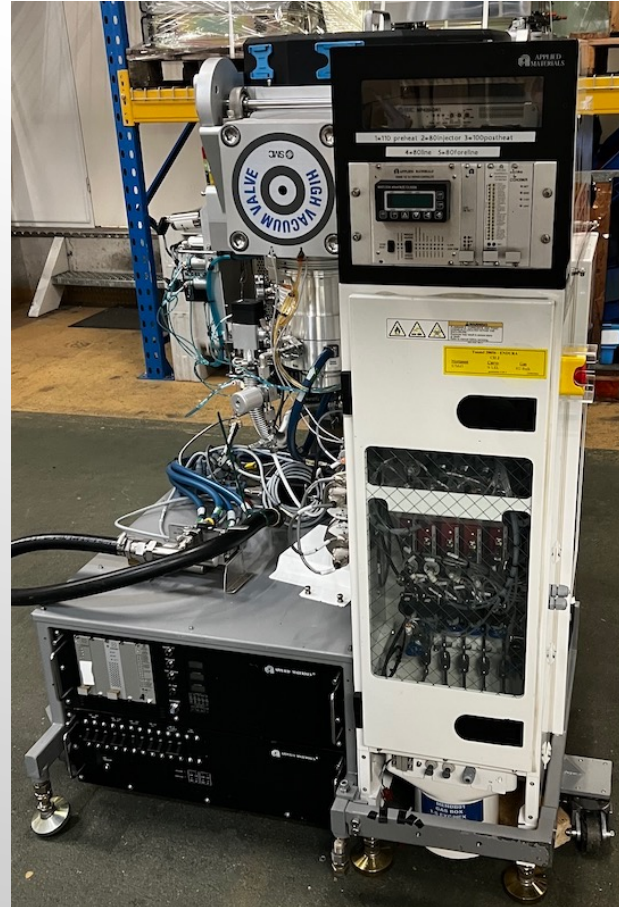
Gaspanel with Mykrolis Intelliflow II MFC's  
 Gasbox Type STAR 2,5L TIN

#### Process kit included

0021-19312	Plate, blocker TXZ, 300
0021-12855	Housing Quartz Tube TXZ
0021-96968	Bushing
0040-64429	Lid, 300mm TXZ
0040-08494	Water Box, TXZ 300mm CVD
0040-03617	Manifold, Lid Ga/Water
0040-53873	Output Manifold, Gas, 300mm
0041-31335	Plate, Gas Distribution, TXZ 300
0200-03587	Tube, Gas Feed
0020-02421	Isolator, Lid top Ceramic
0020-48621	TXZ Ring Edge Al SST HJR 300mm
0021-07586	Ring Middle Purge SST, 300mm
0021-07519	Screw. CenMering Purge Heater
0040-04586	inner Shield
0021-07984	Outer Shield
0200-00531	Ceramic insert
0200-36399	Ceramic Top Shield
0021-22794	Lift Pins
0021-23572	Chamber Plug, 300mm TXZ
0021-15605	Upper, shield Exhaust, 300mm TXZ
0020-64708	Chamber Exhaust Liner, 300mm TXZ
0200-35814	Tube Gas Feed
0040-02937	Water Manifold
0020-38853	Bushing
0021-39403	Block



**Applied Materials Enhanced CVD TxZ Process chamber  
Vintage 2007 300mm  
Location warehouse Nijmegen condition "As is"**



# Solutions on Silicon BV

*Your service partner for LAM Research Equipment*

- **Equipment Support**  
PM, CM, Trouble shooting, Upgrading, Training and Onsite Service Contracts
- **Process Support**  
Process design, Improvement, Fab-to-Fab Transfer and Integration
- **Refurbishment**  
From custom to complete refurbishment
- **Relocation**  
Auditing, Fingerprinting, Decommissioning, Installation, Acceptance
- **Materials**  
Supplier of first class second source materials

